

Control System towards FAIR Commissioning

Workshop on Controls Development for FAIR Commissioning and GSI Operation of Existing Acc. Complex

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FAIR Commissioning Phase

Commissioning

"Process of assuring that all systems and components are designed, installed, tested, operated, and maintained according to the design and operational requirements of the project owner (e.g. WPL, equipment specialist, SPL) until the final handover to operation".

Key Aspects of Commissioning

- Comprehensive unit tests → testing procedures, sequences, check-lists
- Definition of interfaces → which & when a given functionality required, definition of entry conditions & lead times to achieve these functionalities)
- Definitions of goals → exit conditions
- Documentation of executed tests

Targets

- Commissioning of the Control System itself
 - → While being the fabric and tool for other equipment, the CS is by itself is a complex collection of sub-systems that also need to be commissioned.
- Control system support to commission accelerator components, systems, the accelerator
 - Individual component/system tests
 - Integration tests
 - Higher level tests → Dry-runs → Commissioning with beam





Control System Commissioning

Iterative Development Approach

The control system is not a monolithic single system that follows (or for the matter can follow) a simple start/stop development paradigm



- CS is a collection of sub-systems bound by a robust middleware, timing system, settings management system, ...
- Evolving standard best tracked by CI (continuous integration), continuous delivery and agile programming paradigms rather linear start/stop, functionality and interfaces are often complex and require re-iterations.

Accelerator Control System Commissioning

- The Controls infrastructure team provides technical networks (Ethernet, Profinet, WR Timing, Interlocks) → pre-requisite for all equipment groups Installation and commissioning of the technical networks as soon as the civil construction progress/conditions allows (and installation makes sense)
- Control system commissioning strategy
 - → test as much at the existing facility prior to starting FAIR hardware commissioning
 - → work out commissioning plans for functions not testable at existing machines





Control System Commissioning Support

Commissioning Support

CS needs to provide tools to support to commission components, systems, the accelerator

- Individual component/system tests (responsibility WPL)
- System integration tests
- Higher level tests → Dry-runs → Commissioning with beam (responsibility SPL)

Essential tools for this phase:

- Sequencer service (automation, semi-automation)
- Archiving (measurement DB) to store test results and PM data
- Diagnostic logging system

Further technical support requests shall be identified after the FAIR machine presentations of this workshop





Sequencing and Semi-Automation

Sequencer

- Essential tool for operation and commissioning
- Sequencer service under development → presentation by Stefan Krepp (ACO)
- Optimize routine tasks so that operation crew and commissioning team can focus on more important tasks that cannot be automated
- Sequencer tasks: big time-saver for large-scale equipment acceptance/integration tests, recommissioning, or dry-runs

Testing Approach

- Controls provides the sequencer service ("the tool")
 however: exploitation of the sequencer needs to be done by users
- Users need to define precise test procedures, entry conditions, dependencies to other systems, etc.
- User writes sequences/tasks with the sequencer (code)
- Controls can support coding of sequences/tasks on best effort and resource capacity
- Equipment specialists need to follow complete development cycle of their equipment (including controls integration)
- Lead-times must be considered (i.e. resource load)
- need to practise on small scale tests before ramping up procedures to full FAIR

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The control system is not exclusively the product of the Controls department, several other departments/partners contribute to the full set of the CS

→ Biggest workload/effort is software development

Overview table for Software Development prepared* (Draft RFC)

- Tool to visualize, organize, and prioritize developments
- Harmonize and coordinate developments, avoid (unintended) double-developments
- Define clear scope of responsibilities

→ Table should be carefully reviewed by the sub-projects

further input should be added, suggestions to improve welcome!

Definition of priorities:

- 1: Essential function: no operation without
- 2: Important function: operation at the expense of personnel resources & (in)efficiency
- 3: Required function for quality- and high intensity operation
- 4: Operation with degraded operational efficiency possible

Project phases:

HWC: Hardware commissioning

BC: Beam commissioning

OP: Operation



^{*}special thanks to SIS100 project team (Spiller/Ondreka/Steinhagen)







	Activities	П	_	Т	Exc	ecut	ing [Depa in SW do	rtme	SPL		Phase Phase		Prio	S4-4					
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	Description	Kürzel	ACO	BIT	BEA	SFR	SRP	RRF	OPE	SYS	DEC	APH	CRY E	XP	Antorderer	HWC (& controls)	BC (& dry runs)	OP (user)	siehe rechts)	
	Cryogenic Controls			·			y	y												
	Cry plant (Cryo2) control (integration only)														СОМ				11	
	Cryo distribution control				ļ										СОМ				1	
	SIS100 dynamic load predictions			<u> </u>			<u> </u>	L	<u> </u>	<u> </u>		<u> </u>			SIS				3	
	Vauum Controls											,			СОМ					
	Vacuum control and safety		#												СОМ				1	
	Cryo insulation vacuum control														сом		ļ		1	
	Building services engineering (TGA) Monitoring			Y			Y	Y												
	Monitoring of accelerator media				ļ							ļ							4	
	Electrical load monitoring (pulse/common mains)														SIS				3	
	Cooling water temperatures				ļ														4	
	Cooling plants	-			ļ			ļ			ļ	ļ	ļ			-			4	
	Ventilation/colling			<u> </u>	<u> </u>		L	L	<u> </u>	<u> </u>	<u> </u>	<u> </u>	<u> </u>							
	Sequential Facility Control incl. Apps	Timing			Υ	Υ	:			Y	· · · · · · · · · · · · · · · · · · ·	Y	YY						11	
	Timing Master				ļ							ļ			ACC				1	
	Timing Director				ļ					_	-	ļ	-		ACC EXP				•	
	Request Processor	BSS Control			ļ	ļ					 	ļ	-		ACC				1	
_	Scheduling Pattern Creation	Scheduling App			-	-					-	ļ			ACC				1	
2	Machine and Beam-Mode Control	Scheduling App			ļ	ļ					ļ	ļ			ACC				1	
E	Timing Monitor & Diagnostics							ļ			-				ACC				2	
Q	Personnel Safety														ACC		ļ			
Ę	Radiation Protection System	-		ľ	1			ĭ	T	I	1	I			SRP	-			1	1
Facility Control	Acc. Personnel Access System (PAS)	PAS			-						-	ļ			SRP				1	-
芸	Machine Protection	FAO		ļ			L	L	<u> </u>	<u> </u>		l			SKF					
ŏ	Device Status Monitoring and Interlocking	MASP		Y	1		Ĭ	T		Ī	1	I			all				1	
ш.	Fast-Beam-Abort-System – SIS18/SIS100	FBAS			·			ļ				ļ			SIS				3	
	Fast-Beam-Abort-System - primary beam lines	FBAS			-										010	1			3	
	Fast-Beam-Abort-System – SuperFRS	FBAS			ļ						-	ļ	-		SFR	-			3	
	Fast-Beam-Abort-System – Experimente	FBAS			-						-	ļ			EXP				3	
	Fast BLM System	IDAO			ļ					İ		ļ			LXI				3	
	Permit-Service (Powering, Movable Devices)	MASP																	3	
	Acc. Facility Overview	WAOI														-				
	Status Machine(s)			J															1	
	Beam Production Chain Status																		1	
	Online Timing & Scheduling Monitor	-													ACC				1	
	Status Industrial systems (vac, cryo)				-										700	-			2	
	Fixed-Display (web-based)	-						L		L						-				
	Accelerator Facility Status	1	-	I	Ĭ	Ĭ		I		Ī	Ĭ	Ĭ	Ĭ		ACC	1			1	
	Ind. Machine Status	1			ļ						-	ļ	 		ACC,SIS	-			1	
	Beam-Production-Chain Status	BPC Status			-	<u> </u>						ļ	-		SIS	-			1	
	Experiment Status	Di O Gialus			<u> </u>	-						ļ			EXP.ACC	-			1	
	Machine Availability Analysis Tools			i	<u> </u>	.i	<u></u>	L		İ		L			OPE	-			4	
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	Activities								Depa i n SW de			SPL Requester Anforderer	1 -	Phase Phase	_	Prio (1-4, Erläuterung siehe rechts)	Status			
	Description	Kürzel	ACO	BIT	BEA	SFR	SRP	RRF	OPE	SYS	DEC	APH	CRY	EXP	Antorderer	HWC (& controls)	BC (& dry runs)	OP (user)	siene rechts)	
	Settings Supply						·	γ												
	Device and beam parameter settings	ParamModi													ACC				11	
	Machine modelling	LSA make-rules					<u> </u>	ļ			L		<u> </u>		ACC				1	
	Beam Monitoring			·			Y	Υ			T					ļ				
	Beam-Transmission-Monitoring	ВТМ													ACC	<u> </u>			2	
	Beam-Quality-Monitoring	BQM													SIS,DEC	ļ			3	
	Multi-Parameter-Beam GUI						<u> </u>	<u> </u>			<u> </u>				APE	<u> </u>			3	
	Beam-Based Control Systems			,			·	· · · · · · · · · · · · · · · · · · ·								ļ				
	inj./extr. trajectories (BPM-based)														SIS				1	
	trajectory control HEST	"Benno"													СОМ				2	
	closed-orbit and radial-loop														SIS				1	
	Q/Q' control														SIS				3	
	Multi-Turn-Injection	MTI													SIS,DEC				3	
2 0	Bunch2Bucket beam-transfer	B2B													SIS		><		1	
3se	Slow-Extraction														SIS		><		3	
건 원	Slow extraction optimisation (spill form/structure)																><		2	
e e	optics measurement & correction														SIS				3	
Og	Collimator/Cleaning set-up - SIS100														SIS				3	
Machine Controls (system- and beam-based)	Collimator/Cleaning set-up - SFR														SFR					
-	MPS validation – SIS100														SIS				3	
ာ မွ	MPS validation – Super FRS														SFR					
© 8	beam-cooling optimisation														SIS				3	
2 ~	final-focus control (x/y,x'/y', β,)														СОМ				3	
	RF bunch gymnastics		İ												SIS	1			2	
	Post-Mortem-Analysis					i	i		ž	i		·	å		SIS,SFR				3	
	PM data acquisition readout and persistence	РМ														<u> </u>				
	superconducting magnets (quench analysis)														SIS.SFR				1	
	beam-related losses (FBAS, pBar operation,)														SIS,PLI				3	
	Control local cryogenics						!	.!	i		.i		ik		0.0,					
	Visualisation, semi-automatic control (sensors,								Ĭ		Ĭ		Ĭ		SIS,SFR,					
	pressure, temp., actuators, heater,)												?		СОМ	\times			1	
	Automation processes/sequences												?		SIS, COM				3	
	Other semi-automated procedures					i	I	.1	L		.i	L	LL		,	-				
	Parameter scan		·				Ĭ	<u> </u>							SIS,OPE	 			4	
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	Activities			Executing Departments (directly involved in SW development)													Phase Phase		Prio (1-4, Erläuterung siehe rechts)	Status
	Description	Kürzel	ACO	BIT	BEA	SFR	SRP	RRF	OPE	SYS	DEC	APH	CRY E	EXP	Anforderer	HWC (& controls)	BC (& dry runs)	OP (user)	siene recins)	
	Accelerator equipment control & tools/GUIs	FESA														ĺ			1	1
	Power converter control (all)														COM				1	
	Ring RF equipment control														СОМ				1	
	Pulsed power systems control														СОМ				1	
	Stepping motor control														СОМ	1			1	
	Beam instrumentation systems														СОМ				1	
	Maschine-specific FESA classes (various)			À											СОМ	1			1	
	Digitizer Systems & Generic DAQ App														СОМ				1	
				·												 				
	Expert tools & GUIs (per device/machine)			i					J							-	<u> </u>			
	DCT			Ĭ			Ĭ	Ĭ								†				
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	FCT Ring and Transfer Lines			İ			ļ									 				
Equipment Control	BPM (by type/machine)						İ									 				
늘	RSA, SIS-Radio			ļ												<u> </u>				-
5	Lassie			ļ																+
ŭ	IPM			<u> </u>																<u> </u>
=	BIF			ļ												<u> </u>				
e u	Profile grids			ļ																
Ě	Cameras			<u> </u>																
. <u>⊡</u>	HV control			İ												-				
2	MAPS2															1				
Ш	BIF															1				
_	BTF Scan			<u> </u>												1				
	IonSource GUI						İ									1				
	UNILAC Energy mesasurement (ToF)																			
	Schottky – Machine			<u> </u>											SIS	1			3	
	Schottky – Experiments						İ									1				
																1				
	Fast-Beam-Abort-System (Controller)															1			3	
	Bunch-2-Bucket System (low-level timing)																		1	
	Device Control GUI						Ĭ												1	
	Actual-vs-Reference-Monitoring/Interlocking				1				Ì						SIS			İ	2	
	Integration of generic sensor data and actuators						İ									1		1		
	(e.g. cryogenics, vacuum)																		2	
	Data Concentrators (PBM,)										ł		 			ł	1	ļ	2	
	Data Concentrators (FDIVI,)															\vdash				+



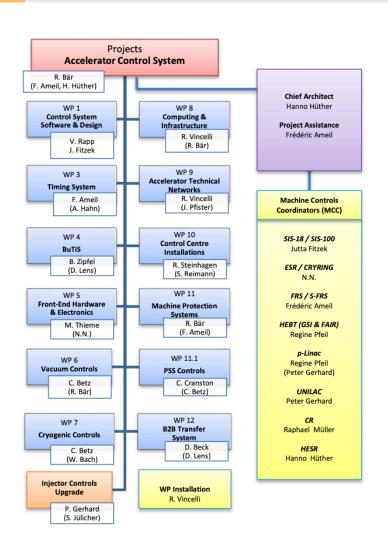


	Activities							ing C			SPL Requester	1 -	Phase Phase	_	Prio (1-4, Erläuterung	Status				
	Description	Kürzel	ACO	ВІТ	BEA	SFR	SRP	RRF	OPE	SYS	DEC	APH	CRY	EXP	Anforderer	HWC (& controls)	BC (& dry runs)	OP (user)	siehe rechts)	
	LSA-Settings-Management	LSA														1				
	Device setting supply (drive)				Ĭ					Ĭ			Ĭ						1	
	Muti-Parameter-Beam infrastructure																		3	
	Management of Critical Settings	MCS											İ						3	
	Front-End Software Architecture	FESA																	1	
S	Generic Control Room Apps (not machine specific)												İ						1	
<u>.ŏ</u>	Beam Request System to users (App, API)																		1	
7	Machine-Experiment Data Exchange Interface								· · · · · · · · · · · · · · · · · · ·										4	
Services	Archiving-Service																			
	Archiving System														ACC			•	1	
Generic	Generic data visualisation and retrieval																			
ē	Role-Based-Access Management	RBAC														1		•	1	
Ĕ	Sequencer Service	Sequencer																	1	
Ğ	Diagnostic Logging																		1	
_	Post-Mortem-System	PM																	1	
	Generic Digitizers (non-BI)														SIS				1	
	Measurement data visualisation	chart-[fx,Qt]													SIS				1	
	Middle-Tier-Services (equip. & beam-based))														SIS				1	
	Accelerator IT cluster system				:	:				:		:							1	
	General services														SIS				1	
0 0	Development environment & tools																		1	
LF	Continous int. & dev. Environment (CI/CD)														SIS				1	
.	Container management services																		2	
5 🖫	Version control systems																		1	
# # # # # # # # # # # # # # # # # # #	Electronic log book (operation)														ACC				1	
as	User-account management (auth services)														ACC				3	
Infrastructure services / für Dienste)	Accelerator Databases			•												1			1	
Infrastructure r services / für Dienste)	Network Infrastructure (technical networks)					A			·	*	A	A	-AA						1	
⊢ ≅	Ethernet, Profinet, White Rabbit																		1	
	Active components (switches, firewall,)											<u> </u>	†						1	
	Technical equipment Control Room (FCC)							İ							ACC	†		•	1	
					†	<u> </u>						<u> </u>	† <u>†</u>			·				

Structured Communication



Controls Internal Organisation



Development and Commissioning phase require clearly structured responsibilities and communication.

MCC (Machine Controls Coordinators)

- Meetings and communication is usually organized "per accelerator"
- MCC serves as contact person for all matters concerning specific machine
- MCC organizes activities for respective machine within the Controls group







thank you!